



Filed Via Express Mail
Rec. No.: EV 096 421 016 US
On: AUGUST 29, 2002

By: *Linda E. Hastings*
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No. 50-1290.

*10/16/02
Muller*

ATTORNEY DOCKET NO. NECK 17.552

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor: Hiroshi TANABE
Serial No.: 09/614,286
Filed: July 12, 2000
Title: **METHOD FOR FORMING SEMICONDUCTOR FILMS
AT DESIRED POSITIONS ON A SUBSTRATE**
Examiner: Timothy J. Sutton
Group Art Unit: 2813

Assistant Commissioner for Patents
Washington, D.C. 20231

RESPONSE TO OFFICE ACTION

Sir:

In response to the Office Action mailed on May 30, 2002, the period for
responding thereto expiring after August 30, 2002, please amend the subject application
as follows:

RECEIVED
SEP - 3 2002
TECHNOLOGY CENTER 2800